

Amendments to the Specification

Please amend the paragraph beginning at page 9, line 18 as follows:

Figs. 2(a) to 2(c) are ~~[[is]]~~ cross-sectional views depicting the manufacturing process of the piezoelectric thin film component;

Please amend the paragraph beginning at page 9, line 20 as follows:

Figs. 3(a) and 3(b) are ~~[[is]]~~ schematics depicting the PZT crystal formation process confirmed by a scanning electron microscopy (SEM);

Please amend the paragraph beginning at page 22, line 1 as follows:

Figs. 3(a) and 3(b) are ~~[[is a]]~~ schematics depicting a PZT crystal formation process confirmed by a scanning electron microscopy (SEM), where ~~[[(1)]]~~ Fig. 3(a) is a drawing along the height direction of the PZT crystal, and ~~[[(2)]]~~ Fig. 3(b) is a drawing along the diameter (width) direction of the PZT crystal. Fig. 4 is its actual electron microscopic photograph, where columnar PZT crystals have been formed on the Pt electrode. The titanium crystals 14A have been formed on the grain boundaries of the bottom electrode crystals 14.